

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Hiroshi Tayanaka DOCKET NO.: P97,0027

SERIAL NO.: 08/818,239 BATCH NO.: B20  
CLASS: 488

DATE FILED: March 14, 1997 EXAMINER: K. Christianson  
GROUP ART UNIT: 2813

INVENTION: "METHOD FOR MAKING THIN FILM SEMICONDUCTOR (AS  
AMENDED)"



EXAMINER: K. Christianson  
GROUP ART UNIT: 2813

**SUBMITTAL OF FORMAL DRAWINGS**

Hon. Assistant Commissioner of Patents  
Washington, D.C. 20231

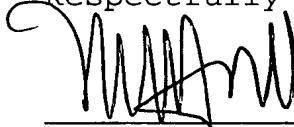
OCT 26 1999

**LETTER TO OFFICIAL DRAFTSMAN**

Enclosed please find **27 sheets** of formal drawings submitted in response to the Notice of Allowability PTOL-37 mailed on September 9, 1999 in connection with the above-identified case.

Applicant respectfully requests that the Examiner indicate that the drawings are acceptable so that the case may be passed to issue in view of the Notice of Allowability mailed on September 9, 1999.

Respectfully submitted,

  
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**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to Assistant Commissioner for Patents, Washington, D.C. 20231 on October 18, 1999.

  
Michael R. Hull